CPC COOPERATIVE PATENT CLASSIFICATION

H ELECTRICITY

(NOTE omitted)

H05 ELECTRIC TECHNIQUES NOT OTHERWISE PROVIDED FOR

H05H PLASMA TECHNIQUE (fusion reactors G21B; ion-beam tubes H01J 27/00; magnetohydrodynamic generators H02K 44/08; producing X-rays involving plasma generation H05G 2/00); PRODUCTION OF ACCELERATED ELECTRICALLY-CHARGED PARTICLES OR OF NEUTRONS (obtaining neutrons from radioactive sources G21, e.g. G21B, G21C, G21G); PRODUCTION OR ACCELERATION OF NEUTRAL MOLECULAR OR ATOMIC BEAMS (atomic clocks G04F 5/14; devices using stimulated emission H01S; frequency regulation by comparison with a reference frequency determined by

energy levels of molecules, atoms, or subatomic particles H03L 7/26)

WARNING

precedence)}

In this subclass non-limiting references (in the sense of paragraph 39 of the Guide to the IPC) may still be displayed in the scheme.

1/00	Generating plasma; Handling plasma	1/14	• • • wherein the containment vessel is straight and
1/0006	• {Investigating plasma, e.g. measuring the degree of	1/1/	has magnetic mirrors
	ionisation or the electron temperature}	1/16	using externally-applied electric and magnetic
1/0012	• • {using electromagnetic or particle radiation, e.g.		fields
	interferometry}	1/18	• • • wherein the fields oscillate at very high
1/0018	{Details}		frequency, e.g. in the microwave range {, e.g.
1/0025	• • • {by using photoelectric means		using cyclotron resonance}
	(<u>H05H 1/0031</u> - <u>H05H 1/0043</u> take	1/20	Ohmic heating
	precedence)}	1/22	• • for injection heating {(G21B 1/15 takes
1/0031	• • {by interferrometry}		precedence)}
1/0037	• • {by spectrometry}	1/24	• Generating plasma {(nuclear fusion reactors
1/0043	• {by using infrared or ultraviolet radiation}		G21B 1/00; gas-filled discharge reactors
1/005	{by using X-rays or alpha rays}		H01J 37/32)}
1/0056	. · {by using X-rays of alpha rays}. · {by using neutrons}	1/2406	• • {using dielectric barrier discharges, i.e. with a
			dielectric interposed between the electrodes}
1/0062	• • {by using microwaves}	1/2418	• • • {the electrodes being embedded in the
1/0068	• • {by thermal means}	-, -, -, -,	dielectric}
1/0075	{Langmuir probes}	1/2425	• • • {the electrodes being flush with the dielectric}
1/0081	• • {by electric means}	1/2431	• • • {using cylindrical electrodes, e.g. rotary
1/0087	• • {by magnetic means}	1/2431	drums }
1/0093	• • {by acoustic means, e.g. ultrasonic}	1/2437	• • • {Multilayer systems}
1/01	• {Handling plasma, e.g. of subatomic particles}	1/2437	• • {Multilayer systems}• • • {Surface discharges, e.g. air flow control}
1/02	 Arrangements for confining plasma by electric or 		
	magnetic fields; Arrangements for heating plasma	1/2441	• • • {characterised by the physical-chemical
	({G21B 1/00 takes precedence;} electron optics		properties of the dielectric, e.g. porous
	<u>H01J</u>)		dielectric}
1/03	using electrostatic fields	1/2443	• • • {the plasma fluid flowing through a dielectric
1/04	using magnetic fields substantially generated by		tube}
	the discharge in the plasma	1/245	• • • • {the plasma being activated using internal
1/06	Longitudinal pinch devices		electrodes}
1/08	• • • Theta pinch devices {, e.g. SCYLLA}	1/246	• • • • {the plasma being activated using external
1/10	• using externally-applied magnetic fields only {,		electrodes (<u>H05H 1/245</u> takes precedence)}
1/10	e.g. Q-machines, Yin-Yang, base-ball}	1/2465	• • • { the plasma being activated by inductive
1/105	• • {using magnetic pumping}		coupling, e.g. using coiled electrodes}
1/103	 (using magnetic pumping) using cusp configuration (<u>H05H 1/14</u> takes 	1/247	• • {using discharges in liquid media}
1/11	precedence)	1/2475	• {using acoustic pressure discharges}
1/10	•	1/2481	• • • {the plasma being activated using piezoelectric
1/12	• • • wherein the containment vessel forms a closed		actuators}
	or nearly closed loop {(G21B 1/05 takes		

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1/0/107		1 / 477	(' 1' 1)
1/2487	• • • {the plasma being activated using mechanical	1/47	• • {using corona discharges}
4/2402	actuators}	1/471	• • • {Pointed electrodes}
1/2493	• • • {the plasma being activated using horns}	1/473	• • • {Cylindrical electrodes, e.g. rotary drums}
1/26	Plasma torches	1/475	• • • {Filamentary electrodes}
1/28	Cooling arrangements	1/477	• • • {Segmented electrodes}
1/30	using applied electromagnetic fields, e.g. high	1/48	• using an arc (H05H 1/26 takes precedence)
	frequency or microwave energy (H05H 1/28	1/481	• • • {Hollow cathodes}
	takes precedence)	1/482	• • • {Arrangements to provide gliding arc
1/32	• • using an arc (<u>H05H 1/28</u> takes precedence)	1/402	discharges}
1/34	Details, e.g. electrodes, nozzles	1/484	• • • {Arrangements to provide plasma curtains or
1/3405	{Arrangements for stabilising or	1/404	plasma showers}
1/5/105	constricting the arc, e.g. by an additional	1/106	- · · · · · · · · · · · · · · · · · · ·
	gas flow}	1/486	• • {Arrangements to provide capillary discharges}
1/341	{Arrangements for providing coaxial	1/488	{Liquid electrodes}
1/341	protecting fluids}	1/50	• • • and using applied magnetic fields, e.g. for
1/2/21			focusing or rotating the arc
1/3421	• • • • {Transferred arc or pilot arc mode}	1/52	• using exploding wires or spark gaps (<u>H05H 1/26</u>
1/3423	{Connecting means, e.g. electrical		takes precedence; spark gaps in general <u>H01T</u>)
	connecting means or fluid connections}	1/54	Plasma accelerators
1/3425	• • • • {Melting or consuming electrodes}		
1/3431	• • • • {Coaxial cylindrical electrodes}	3/00	Production or acceleration of neutral particle
1/3436	• • • • {Hollow cathodes with internal coolant		beams, e.g. molecular or atomic beams
	flow}	3/02	 Molecular or atomic beam generation {(charge
1/3442	{Cathodes with inserted tip}		exchange devices <u>G21K 1/14</u> ; polarising devices
1/3447	{Rod-like cathodes}		G21K 1/16; using resonance or molecular beams for
	,		analysing or investigating materials G01N 24/002;
1/3452	{Supplementary electrodes between		atomic clock <u>G04F 5/14</u> ; beam masers <u>H01S 1/06</u>)
	cathode and anode, e.g. cascade}	3/04	Acceleration by electromagnetic wave pressure
1/3457	• • • • {Nozzle protection devices}	3/06	Generating neutron beams (targets for producing)
1/3463	• • • • {Oblique nozzles}	3/00	nuclear reactions <u>H05H 6/00</u> ; neutron sources
1/3468	• • • • {Vortex generators}		G21G 4/02)
1/3473	{Safety means}		<u>0210 4102</u>)
1/3478	{Geometrical details}	5/00	Direct voltage accelerators; Accelerators using
1/3484	{Convergent-divergent nozzles}		single pulses (H05H 3/06 takes precedence)
1/3489	{Means for contact starting}	5/02	Details (targets for producing nuclear reactions
		0,02	H05H 6/00)
1/3494	• • • • {Means for controlling discharge	5/03	Accelerating tubes (vessels or containers of
4 (0.4	parameters}	3/03	electric discharge tubes with improved potential
1/36	Circuit arrangements (<u>H05H 1/38</u> ,		distribution over surface of vessel <u>H01J 5/06</u> ;
	<u>H05H 1/40</u> take precedence)		shields of X-ray tubes associated with vessels or
1/38	• • • • Guiding or centering of electrodes		containers H01J 35/16)
1/40	using applied magnetic fields, e.g.	5 (0.4	
	for focusing or rotating the arc {(cf.	5/04	• energised by electrostatic generators
	<u>B23K 9/08, B23K 9/073</u>)}	5/042	• • {of the van de Graaf type}
1/42	• • • with provisions for introducing materials	5/045	• • {High voltage cascades, e.g. Greinacher cascade}
	into the plasma, e.g. powder, liquid ({arc	5/047	• • {Pulsed generators}
	stabilising or constricting arrangements	5/06	Multistage accelerators
	H05H 1/3405; coaxial protecting fluids	5/063	{Tandems}
	H05H 1/341;} electrostatic spraying,	5/066	{Onion-like structures}
	spraying apparatus with means for charging	5/08	• Particle accelerators using step-up transformers, e.g.
	the spray electrically <u>B05B 5/00</u> {; cf.	3/00	resonance transformers
	B23K 9/324, B05B 7/22})		resonance transformers
1/44	using more than one torch	6/00	Targets for producing nuclear reactions (supports
			for targets or objects to be irradiated G21K 5/08 {;
1/46	• using applied electromagnetic fields, e.g. high		preparation of tritium C01B 4/00; targets, e.g. pellets
	frequency or microwave energy (<u>H05H 1/26</u> takes		for fusion reactions by laser or charged particles beam
1/461	precedence)		for fusion reactions by laser or charged particles beam injection H05H 1/22})
	precedence) {Microwave discharges}	2006/002	injection <u>H05H 1/22</u> })
1/4615	precedence) {Microwave discharges} {using surface waves}	2006/002	injection H05H 1/22}) • {Windows}
	precedence) {Microwave discharges}	2006/002 6/005	 injection H05H 1/22}) • {Windows} • {Polarised targets (polarising devices, e.g. for
1/4615	precedence) {Microwave discharges} {using surface waves}	6/005	 injection H05H 1/22}) • {Windows} • {Polarised targets (polarising devices, e.g. for obtaining a polarised ion beam G21K 1/16)}
1/4615 1/4622 1/463	precedence) {Microwave discharges} {using surface waves} {using waveguides} {using antennas or applicators}		 injection H05H 1/22}) • {Windows} • {Polarised targets (polarising devices, e.g. for
1/4615 1/4622 1/463 1/4637	precedence) {Microwave discharges} {using surface waves} {using waveguides} {using antennas or applicators} {using cables}	6/005	 injection H05H 1/22}) • {Windows} • {Polarised targets (polarising devices, e.g. for obtaining a polarised ion beam G21K 1/16)} • {Radiation protection arrangements, e.g. screens}
1/4615 1/4622 1/463 1/4637 1/4645	precedence) {Microwave discharges} {using surface waves} {using waveguides} {using antennas or applicators} {using cables} {Radiofrequency discharges}	6/005	 injection H05H 1/22}) {Windows} {Polarised targets (polarising devices, e.g. for obtaining a polarised ion beam G21K 1/16)} {Radiation protection arrangements, e.g. screens} Details of devices of the types covered by groups
1/4615 1/4622 1/463 1/4637 1/4645 1/4652	precedence) {Microwave discharges} {using surface waves} {using waveguides} {using antennas or applicators} {using cables} {Radiofrequency discharges} {using inductive coupling means, e.g. coils}	6/005 2006/007 7/00	 injection H05H 1/22}) {Windows} {Polarised targets (polarising devices, e.g. for obtaining a polarised ion beam G21K 1/16)} {Radiation protection arrangements, e.g. screens} Details of devices of the types covered by groups H05H 9/00, H05H 11/00, H05H 13/00
1/4615 1/4622 1/463 1/4637 1/4645	precedence) {Microwave discharges} {using surface waves} {using waveguides} {using antennas or applicators} {using cables} {Radiofrequency discharges} {using inductive coupling means, e.g. coils} {using capacitive coupling means, e.g.	6/005	 injection H05H 1/22}) {Windows} {Polarised targets (polarising devices, e.g. for obtaining a polarised ion beam G21K 1/16)} {Radiation protection arrangements, e.g. screens} Details of devices of the types covered by groups H05H 9/00, H05H 11/00, H05H 13/00 {Arrangements for beam delivery or irradiation
1/4615 1/4622 1/463 1/4637 1/4645 1/4652	precedence) {Microwave discharges} {using surface waves} {using waveguides} {using antennas or applicators} {using cables} {Radiofrequency discharges} {using inductive coupling means, e.g. coils}	6/005 2006/007 7/00	 injection H05H 1/22}) {Windows} {Polarised targets (polarising devices, e.g. for obtaining a polarised ion beam G21K 1/16)} {Radiation protection arrangements, e.g. screens} Details of devices of the types covered by groups H05H 9/00, H05H 11/00, H05H 13/00

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2007/004	{for modifying beam energy, e.g. spread out	13/00	Magnetic resonance accelerators; Cyclotrons
2007/005	Bragg peak devices}	12/005	{(strophotrons, turbine tubes <u>H01J 25/62</u>)}
2007/005	• • {for modifying beam emittance, e.g. stochastic cooling devices, stripper foils}	13/005 13/02	 {Cyclotrons} Synchrocyclotrons, i.e. frequency modulated
2007/007	• • {for focusing the beam to irradiation target}	10,02	cyclotrons
2007/008	• • {for measuring beam parameters}	13/04	• Synchrotrons
7/02	Circuits or systems for supplying or feeding radio-	13/06	Air-cored magnetic resonance accelerators
	frequency energy (radio-frequency generators H03B)	13/08	Alternating-gradient magnetic resonance
2007/022	• • {Pulsed systems}	12/005	accelerators
2007/022	{Radiofrequency systems}	13/085	• • {Fixed-field alternating gradient accelerators
2007/023	{Kadion equency systems} {Microwave systems}	13/10	[FFAG]} • Accelerators comprising one or more linear
7/04	Magnet systems {, e.g. undulators, wigglers (free-	13/10	accelerating sections and bending magnets or the
	electron laser <u>H01S 3/0903</u>)}; Energisation thereof		like to return the charged particles in a trajectory
2007/041	• • {for beam bunching, e.g. undulators}		parallel to the first accelerating section, e.g.
2007/043	• • {for beam focusing}		microtrons {or rhodotrons}
2007/045	• • {for beam bending}	15/00	Methods or devices for acceleration of charged
2007/046	• • {for beam deflection}		particles not otherwise provided for {, e.g.
2007/048	• • {for modifying beam trajectory, e.g. gantry		wakefield accelerators}
7/06	systems}	2240/00	Testing
7/06	• Two-beam arrangements; Multi-beam arrangements	2240/00	Testing
2007/065	{storage rings}; Electron rings	2240/10	at atmospheric pressure
2007/065	{Multi-beam merging, e.g. funneling}	2240/20	Non-thermal plasma
7/08	Arrangements for injecting particles into orbits	2242/00	Auxiliary systems
2007/081	{Sources}	2242/10	Cooling arrangements
2007/082	{Ion sources, e.g. ECR, duoplasmatron, PIG,	2242/20	• Power circuits
2007/094	laser sources)	2242/22	DC, AC or pulsed generators
2007/084 2007/085	(hy electrostatic magne)	2242/24	Radiofrequency or microwave generators
	(by magnetic means)	2242/26	Matching networks
2007/087	(by magnetic means)		- -
2007/088	• • {by mechanical means, e.g. stripping foils}	2245/00	Applications of plasma devices
7/10	• Arrangements for ejecting particles from orbits	2245/10	Treatment of gases
7/12	Arrangements for varying final energy of beam	2245/15	Ambient air; Ozonisers
2007/122 2007/125	(by machanical magnetic death faile)	2245/17	. Exhaust gases
2007/123	• {by mechanical means, e.g. stripping foils}• {by emittance variation, e.g. stochastic cooling}	2245/20	Treatment of liquids
7/14	• Vacuum chambers (H05H 5/03 takes precedence)	2245/30	Medical applications
7/14	• of the waveguide type	2245/32	Surgery, e.g. scalpels, blades or bistoury; Treatments inside the body
7/18	Cavities; Resonators {(travelling-wave tubes)	2245/34	3
//16	H01J 23/18; hyperfrequency cavities in general	2243/34	Skin treatments, e.g. disinfection or wound treatment
	<u>H01P 7/04, H01P 7/06</u>)}	2245/36	Sterilisation of objects, liquids, volumes or
7/20	with superconductive walls		surfaces
7/22	. Details of linear accelerators, e.g. drift tubes	2245/40	Surface treatments
	(<u>H05H 7/02</u> - <u>H05H 7/20</u> take precedence)	2245/42	Coating or etching of large items
2007/222	{drift tubes}	2245/50	Production of nanostructures
2007/225	• • {coupled cavities arrangements}	2245/60	Portable devices
2007/227	• • {power coupling, e.g. coupling loops}	2245/70	Automotive applications, e.g. engines
9/00	Linear accelerators	2245/80	Burners or furnaces for heat generation, for fuel
9/005	• {Dielectric wall accelerators}		combustion or for incineration of wastes
9/02	Travelling-wave linear accelerators { (travelling-	2277/00	Applications of particle accelerators
2/02	wave tubes H01J 25/34)}	2277/10	Medical devices
9/04	• Standing-wave linear accelerators	2277/10	Radiotherapy
9/041	{Hadron LINACS}		
9/042	{Drift tube LINACS}	2277/113 2277/116	Diagnostic systems Isotope production
9/044	{Coupling cavity LINACS, e.g. side coupled}	2277/116	Isotope production Ion implantation
9/045	{Radio frequency quadrupoles}	2277/13	Nuclear physics, e.g. spallation sources, accelerator
9/047	{Hybrid systems}	22///13	driven systems, search or generation of exotic
9/048	. {Lepton LINACS}		elements
		2277/14	Portable devices
11/00	Magnetic induction accelerators, e.g. betatrons	2277/1405	Detection systems, e.g. for safety
11/02	Air-cored betatrons		, , , , , , , , , , , , , , , , , , , ,
11/04	Biased betatrons		

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